

Notic of References Cited

Application/Control No. 09/873,041

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Applicant(s)/Patent Under Reexamination HEUKEN ET AL.

Art Unit

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Examiner

Matthew J Song

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NON-PATENT DOCUMENTS

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	U	Schmitz et al. "MOVPE growth of InGaN on sapphire using growth initation cycles". Material Science and Engineering B 43 (1997) pgs 228-236
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.